

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

Takeshi MATSUNUMA

Application No. Unassigned

Art Unit: Unassigned

Filed: July 31, 2003

Examiner: Unassigned

For: METHOD FOR MANUFACTURING
SEMICONDUCTOR DEVICE
THROUGH USE OF MASK MATERIAL

PRELIMINARY AMENDMENT

Mail Stop Patent Application
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

Prior to the examination of the above-identified patent application, please enter the following amendments and consider the following remarks.